

<b>Notice of References Cited</b>	Application/Control No. 10/820,664	Applicant(s)/Patent Under Reexamination PHUA ET AL.	
	Examiner William M. Brewster	Art Unit 2823	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-6,797,593 B2	09-2004	Chakravarthi et al.	438/514
X	B	US-6,306,710 B1	10-2001	Long et al.	438/279
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stanley Wolf Ph.D. and Richard N. Tauber Ph.D. in Silicon Processing for the VLSI Era, Volume 1: Process Technology, Lattice Press, 1986, pp. 191-4.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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